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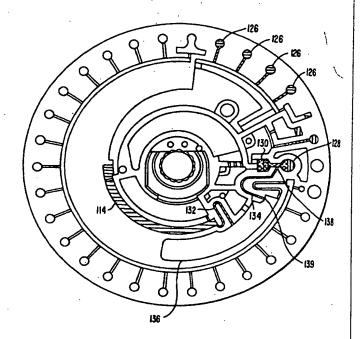
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(54) Title: MODIFIED SIPHONS FOR IMPROVED METERING PRECISION

The present invention provides force centrifugal rotors for delivering a liquid to a chamber in the rotor. In particular the rotors comprise siphons (134) for delivering a premeasured volume of liquid between a first and liquid between a first and a second chamber (136) in the rotor. The siphons (134) of the invention are designed such that the inlet (138) of the siphon on the first chamber is radially outward of the siphon outlet (139) on the first cand between the conditions of the siphon outlet (139) on the candidate of the siphon outlet (139). on the second chamber (136). The first chamber is emptied to a level equivalent to the radial position of the siphon outlet (139).



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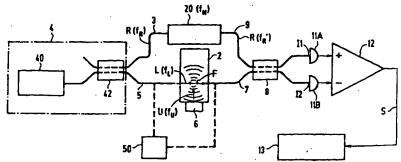
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(54) Title: METHOD AND DEVICE FOR IMAGING AN OBJECT USING LIGHT



(57) Abstract

In the method proposed, examination light (L) and focussed ultrasonic radiation (U) are beamed into an object (2). After it has passed through the object (2), the examination light (L) is superimposed in an interferometer on reference light (R) which is coherent with the examination light (L). The intensity or amplitude of the resulting interference light (I) provides information for an image point which corresponds to the image of the part of the object (2) lying in the zone of focus (F) of the focussed ultrasonic radiation (U).